

Notice of References Cited	Application/Control No. 10/633,162	Applicant(s)/Patent Under Reexamination WAKABAYASHI ET AL.	
	Examiner Mark K. Han	Art Unit 3767	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,913,844	06-1999	Ziembra et al.	604/154
*	B	US-2004/0073161	04-2004	Tachibana, Yasuharu	604/067
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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